



Attorney's Docket No.: 006601.P005C  
Confirmation No.: 4378

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	)	
	)	
Jae Heon Park	)	
	)	Examiner: Underwood, Donald W.
Application No: 10/618,175	)	
	)	Art Unit: 3652
Filed: July 11, 2003	)	
	)	
For: APPARATUS FOR PROCESSING	)	
WAFERS	)	
_____	)	

Mail Stop: Amendment  
Commissioner For Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated August 4, 2004, Applicant respectfully requests that the above-identified application be amended as follows and that the following remarks be considered:

FIRST-CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on:

November 4, 2004

Date of Deposit

Esther Campbell

Name of Person Mailing Correspondence

  
Signature

November 4, 2004

Date

Inventor(s): Jae Heon Park  
Application No.: 10/618,175

Examiner: Underwood, Donald W.  
Art Unit: 3652